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PTO/SB/21 (12-97)

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Application Number	09/625,336
Filing Date	7/25/2000
First Named Inventor	Kori, Moris
Group Art Unit	Unassigned
Examiner Name	Unassigned
Total Number of Pages in This Submission	5
Attorney Docket Number	4742/AMI-00-07

ENCLOSURES (check all that apply)

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Remarks		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual name	Kenneth C. Brooks
Signature	
Date	October 17, 2000

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on this date:			
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3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kori et al.

PATENT APPLICATION

Serial No: 09/625,336

Group Art Unit: unassigned

Filed: July 25, 2000

Examiner: unassigned

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF
FLUORINE IN REFRACTORY METAL LAYERS

Supplemental Information Disclosure Statement

Hon. Assistant Commissioner

for Patents

Washington, D.C. 20231

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. A copy of each reference recited below accompanies this document.

PATENT DOCUMENTS

<u>Patent Number</u>	<u>Inventors</u>	<u>Grant Date</u>
5,972,430	DiMeo, Jr. et al.	Oct. 26, 1999
5,916,365	Sherman	Jun. 29, 1999
<u>Application Number</u>	<u>Inventors</u>	<u>Filing Date</u>
09/678,266	Xi et al.	Oct. 3, 2000



NON-PATENT DOCUMENTS

Choi, et al., The Effect of Annealing on Resistivity of Low Pressure Chemical Vapor Deposited Titanium Diboride. J. Appl. Phys. 69 (11), 1 June 1991. Pages 7853-7861.

Choi et al. Stability of TiB_2 as a Diffusion Barrier on Silicon. J. Electrochem. Soc. Vol. 138, No. 10, October 1991. Pages 3062-3067.

Respectfully submitted,

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Reg. No. 38,393